

JUL 09 2001

Attorney Docket No.: 19930-001200US

Application No.: Unassigned

LIST OF PATENTS AND PUBLICATIONS FOR
 APPLICANT'S INFORMATION DISCLOSURE
 STATEMENT (Use several sheets if necessary)

Applicant: Samuel P. Weaver et al.

Filing Date: February 13, 2001

Group: 2633

Reference Designation

U.S. PATENT DOCUMENTS

Page 1

Examiner Initial	Document No.	Date	Name	Class	Sub-class	Filing Date (If Appropriate)
JPR-AA	5,999,672	12/07/99	Hunter et al.	385	37	
JPR-AB	6,097,519	08/01/00	Ford et al.	359	130	
JPR-AC	6,097,859	08/01/00	Solgaard et al.	385	17	
JPR-AD	6,108,471	08/22/00	Zhang et al.	385	37	
AE						
AF						
AG						
AH						
AI						
AJ						
AK						
AL						

RECEIVED

'JUL 11 2001

Technology Center 2600

FOREIGN PATENT DOCUMENTS

	Document No.	Date	Country	Class	Sub-class	Translation (Yes/No)
AM						
AN						
AO						
AP						
AQ						
AR						

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

JPR-AS	"Low Voltage Piezoelectric Stacks," Transducer Elements, Catalog #3 1998, pp. 30-45, Piezo Systems, Inc. Cambridge, MA 02139
JPR-AT	Grade, John D. et al., "A Large-Deflection Electrostatic Actuator For Optical Switching Applications," Solid-State and Actuator Workshop, Hilton Head Island, SC, pp. 97-100 (June 2000)
AU	
AV	
AW	
AX	

EXAMINER

DATE CONSIDERED

4/16/03

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.